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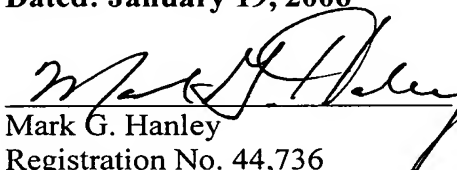
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants : KIM et al.  
U.S. Serial No. : 10/747,599  
Filed : December 29, 2003  
Title : "Methods for Fabricating a  
Semiconductor Device"  
  
Art Unit : 1763  
Examiner : George A. Goudreau

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**Dated: January 19, 2006**

  
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**RESPONSE TO THE OFFICE ACTION DATED DECEMBER 20, 2005**

Mail Stop Amendments  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Office action dated December 20, 2005, please enter the  
following amendments and consider the following remarks:

**Amendments** to the claims begin on page 2 of this paper.

**Remarks** begin on page 4 of this paper.